

Electronic Patent Application Fee Transmittal

Application Number:	08893917			
Filing Date:	11-Jul-1997			
Title of Invention:	REMOTE PLASMA CLEANING SOURCE HAVING REDUCED REACTIVITY WITH A SUBSTRATE PROCESSING CHAMBER			
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Filer:	William Leland Shaffer/Kristina Alvarez			
Attorney Docket Number:	A2119/T21300			
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Patent-Appeals-and-Interference:				
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